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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Application of :  
Toshiaki FUJII :  
Appln. No. 10/563,515 :  
Filed: February 2, 2006 : Art Unit - 1743  
For: METHOD OF MAKING LAMINA :  
SAMPLE AND COMPOSITE :  
CHARGED PARTICLE BEAM :  
APPARATUS : Docket No. S004-5698 (PCT)

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Mail Stop Amendment  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT  
UNDER PATENT RULES 97 AND 98**

S I R:

Applicant submits this information disclosure  
statement pursuant to 37 CFR §§1.97 and 1.98.

MAILING CERTIFICATE ON PAGE 3

This application has not received a first Office Action on the merits. Accordingly, this information disclosure statement is being filed under 37 CFR §1.97(b)(3), i.e., before the mailing date of a first Office Action on the merits.

**Information Disclosure Statement**

Pursuant to 37 CFR §1.98, a list of patents, publications or other information submitted for consideration by the PTO is provided on annexed Form PTO-1449. A legible copy of each item of information listed on the Form is submitted herewith.

Consideration of this information disclosure  
statement is respectfully requested.

Respectfully submitted,

ADAMS & WILKS  
Attorneys for Applicant

By: 

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Reg. No. 25,386

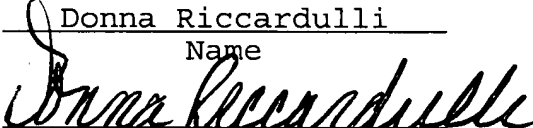
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**MAILING CERTIFICATE**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to: Mail Stop Amendment, COMMISSIONER FOR PATENTS, P.O. Box 1450, Alexandria, VA 22313-1450, on the date indicated below.

Donna Riccardulli

Name



Signature

JULY 28, 2008

Date